

Docket No.: 50432-067

*SS Stevenson*  
*# 5/9*  
*10-10-01*  
PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Kai YANG, et al.

Serial No.:

Group Art Unit:

Filed: March 27, 2001

Examiner:

For: STABILIZING FLUORINE ETCHING OF LOW-K MATERIALS

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
Washington, DC 20231

Sir:

Prior to examination of the above-referenced application, please amend the application as

follows:

IN THE TITLE:

Please change the title from "DAMASCENE PROCESSING USING DIELECTRIC

BARRIER FILMS" to --~~STABILIZING FLUORINE ETCHING OF LOW-K MATERIALS~~--.

**REMARKS**

Entry of this preliminary amendment is respectfully requested.

Respectfully submitted,

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